IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

OPE	n PATEN	Γ APPLICATION Of:	Group Art Unit: 1756 Examiner: To Be Assigned		#5
MAI STREET & TREE	plicants	: Minoru WATANABE)		
278100	Serial No.	: 10/025,783)	INFORMATION	
	Filed	: December 26, 2001))	DISCLOSURE STATEMENT	
	For	: METHOD AND APPARATUS FORMING RESIST PATTERN	FOR)		
	Attorney Ref.	: MAE 223 C1	·)_	May 22, 2002	PECEU
	Commissioner Washington, D			7°C	ACEIVED

This is an information disclosure statement submitted in compliance with the timing requirements of 37 C.F.R. §1.97(b)(3), i.e., prior to a First Office Action on the Merits.

Attached are copies of one U.S. patent document, and two Japanese patent publications, the relevance of which may be gleaned from the English-language translations. The publications are listed on the attached Form PTO-1449.

Since this Information Disclosure Statement is being filed before the First Office Action, no certification or fee is required, and the requirements of 37 C.F.R. §§1.97 and 1.98 are deemed to be fully met as to all documents submitted. Consideration of the submitted documents is respectfully requested.

Respectfully submitted.

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Sir: